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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Wayne Chen et al.
Assignee: KLA-Tencor Corporation
Title: System and Methods for Classifying Anomalies of Sample Surfaces
Application No.: 10/613,634 Filing Date: July 3, 2003
Examiner: Michael Patrick Stafira Group Art Unit: 2877
Docket No.: TNCR.178US1 Conf. No.: 4612

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is in response to the Office Action dated July 28, 2004, setting a period for response expiring on October 28, 2004. A Petition for Extension of Time requesting a one-month extension is herewith enclosed to extend the period for response until November 29, 2004, November 28 being a Sunday.

Amendments to the Claims are not being made.

Amendments to the Specification begin on page 5 of this paper.

Amendments to the Drawings begin on page 6 of this paper.

Remarks begin on page 7 of this paper.